Electronic Patent	App	olication Fe	e Transn	nittal			
Application Number:	10	10598469					
Filing Date:							
Title of Invention:	М	Multilayer Substrate Manufacturing Method					
First Named Inventor/Applicant Name:	Та	Takeshi Nakamura					
Filer:	Sa	Samuel Borodach/Gina Maldonado					
Attorney Docket Number:	14	14225-112US1 F1040898US00					
Filed as Large Entity							
U.S. National Stage under 35 USC 371 F	iling	Fees					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Late filing fee for oath or declaration		1051	1	130	130		
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension of Time:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$) 1			130